


<b>Search Notes</b>  	<b>Application/Control No.</b>  10586991	<b>Applicant(s)/Patent Under Reexamination</b>  VORDE ET AL.
	<b>Examiner</b>  HENG M CHAN	<b>Art Unit</b>  1728

SEARCHED			
Class	Subclass	Date	Examiner
423	387	09/17/2008	/HMC/
149	delimited by text searching	09/24/2008	/HMC/
All searches updated		1/21/2009	/HMC/
564	59, 58	7/27/2009	HMC
ALL SEARCHES UPDATED		7/27/2009	HMC
UPDATED		3/2/2010	HMC
UPDATED		8/19/2010	HMC
updated		4/8/2011	HMC
149	109.6,88,122	4/8	HMC
423	385,400,406	4/8	HMC
564	107,109,61	4/8	HMC

SEARCH NOTES		
Search Notes	Date	Examiner
databases in EAST: US-PGPUB; USPAT; USOCR	9/17/2008	/HMC/
inventors searched in Palm	1/21/2009	/HMC/
All searches updated	1/21/2009	/HMC/
ALL SEARCHES UPDATED	7/27/2009	HMC
EAST databases: US-PGPUB; USPAT; USOCR, EPO, JPO, FPRS, DERWENT, IBM_TDB	7/27/2009	HMC
Consulted Jerry Lorenzo about independent claims and arguments	7/27/2009	HMC
UPDATED	3/8/2010	HMC
STN search	2/26/2010	HMC
Consulted Carlos Barcena	2/26/2010	HMC
STIC search	3/2/2010	HMC
Consulted Jennifer Michener	3/2/2010	HMC
UPDATED	8/19/2010	HMC
STN searches	8/19	HMC
Consulted Jennifer Michener about response to arguments	8/19	HMC
updated	4/8/2011	HMC
Consulted Carlos Barcena about the chemistry and Jenni Michener about the reason for allowance	4/7/2011	HMC

/H. M. C./ Examiner.Art Unit 1793	
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## INTERFERENCE SEARCH

Class	Subclass	Date	Examiner
149	109.6,88,122	4/8/2011	HMC
423	385,387,400,406	4/8	HMC
564	107,109,59,58,61	4/8	HMC
D03D	23/00, 43/00	4/8	HMC
C01B	21/20, 21/50	4/8	HMC

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Examiner.Art Unit 1793